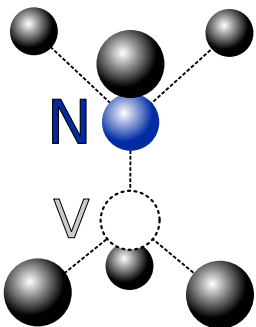
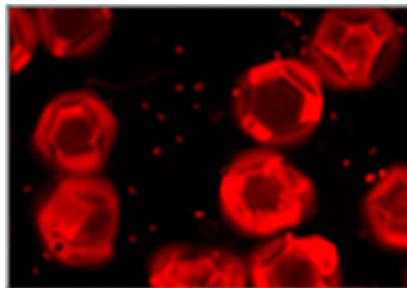


NV center



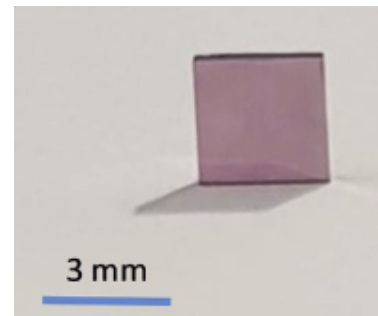
High Pressure High Temperature
(HPHT)



Adamas 15/150 μm

$[\text{NV}] \approx 3 \text{ ppm}$
 $[\text{P1}] \approx 100 \text{ ppm}$

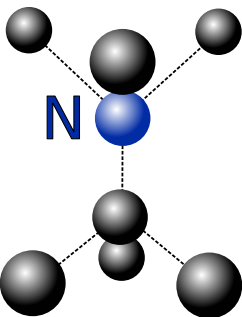
Chemical Vapour Deposition
(CVD)



IRCP-LSPM

$[\text{NV}] \approx 4.5 \text{ ppm}$
 $[\text{P1}] \approx 25 \text{ ppm}$

N_s (P1 center)



Tallaire, A., et al (2020). Carbon, 170, 421-429.